



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 8, 2025	
IGI Report Number	LG740507779
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	SQUARE EMERALD CUT
Measurements	5.54 X 5.51 X 3.47 MM

GRADING RESULTS

Carat Weight	1.02 CARAT
Color Grade	D
Clarity Grade	VVS 2

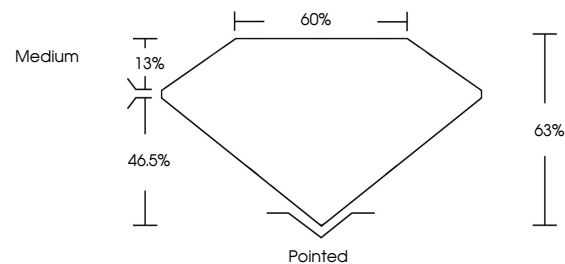
ADDITIONAL GRADING INFORMATION

Polish	VERY GOOD
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG740507779

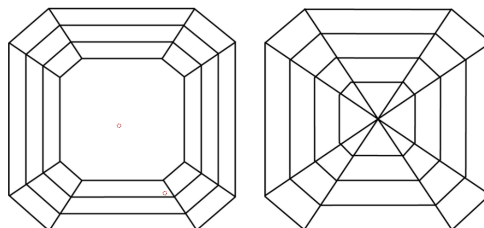
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG740507779
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

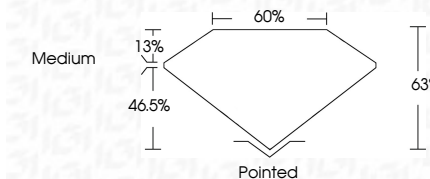
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October 8, 2025
GI Report No LG740507779
SQUARE EMERALD CUT

1.55 X 5.51 X 3.47 MM	1.02 CARAT	
Carat Weight		
Color Grade	VVS 2	68%
		60%
		Medium
		Pointed
		VERY GOOD
		EXCELLENT
		NONE
		4441 1257 05077705

Comments:
This Laboratory Grown Diamond was
created by Chemical Vapor Deposition
(CVD) growth process.